

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
BEFORE THE PATENT TRIAL AND APPEAL BOARD

In re patent of: Chistyakov	§	Petition for <i>Inter Partes</i> Review
	§	
U.S. Patent No. 6,853,142	§	Attorney Docket No.: 34789.98
	§	
Issued: February 8, 2005	§	Customer No.: 27683
	§	
Title: Methods and Apparatus for Generating High-Density Plasma	§	Real Party in Interest: Taiwan Semiconductor Manufacturing Company, Ltd. and TSMC North America Corp.

PETITIONER POWER OF ATTORNEY PURSUANT TO 37 CFR 42.10(b)  
FOR PETITION FOR *INTER PARTES* REVIEW

Petitioners **Taiwan Semiconductor Manufacturing Company, Ltd. and TSMC North America Corp.** hereby appoint the Practitioner(s) associated with **Customer Number 27683**, as its attorney(s) to prosecute and to transact all business in the Patent Trial & Appeal Board of the United States Patent and Trademark Office connected with *Inter Partes* Review of the above-identified patent.

Please direct all communication regarding this Petition to **Customer Number 27683**:

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The undersigned is authorized to sign this Power of Attorney on behalf of the Petitioners.

**Taiwan Semiconductor Manufacturing  
Company, Ltd**

By: 

Printed Name: Michael Shen

Title: DEPUTY DIRECTOR

**TSMC North America Corp.**

By: 

Printed Name: Michael Shen

Title: DEPUTY DIRECTOR